INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 31, 2026

IGI Report Number	LG854643218
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	10.92 X 7.55 X 4.89 MM

GRADING RESULTS

Carat Weight	4.01 CARATS
Color Grade	E
Clarity Grade	VVS 2
Cut Grade	VERY GOOD

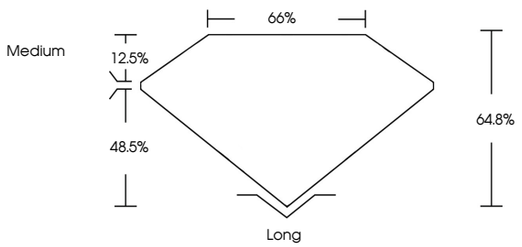
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG854643218

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG854643218
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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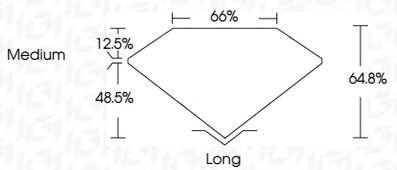
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www.igi.org

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IGI

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EMERALD CUT
10.92 X 7.55 X 4.89 MM
Carat Weight 4.01 CARATS
Color Grade E
Clarity Grade VVS 2
Cut Grade VERY GOOD
Depth 64.8%
Table 66%
Girdle Medium
Culet Long
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG854643218
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Type IIa